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SENT BY: WILSON & HAM;

AUG 19 2005

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PAGE 1

AMENDMENT TRANSMITTAL LETTER Attorney Docket No: INK-001 **Under Small Entity Status** Application Serial Number: Filing Date: Examiner: Group Art Unit: 10/765,613 01/27/2004 Wilson, Lee D. 3723 Invention: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR WAFERS USING ONE OR MORE PIVOTABLE LOAD-AND-UNLOAD CUPS TO THE COMMISSIONER OF PATENTS AND TRADEMARKS: Transmitted herewith is an amendment in the above-identified application. The fee has been calculated as shown below. CLAIMS AS AMENDED CLAIMS REMAINING HIGHEST NUMBER NO. OF EXTRA RATE: ADDITIONAL AFIER AMENDMENT PREVIOUSLY PAID CLAIMS PRESENT FER FOR TOTAL CLAIMS MINUS 38 \$25 38 \$ 0.00 INDEP. CLAIMS 8 MINUS 8 . \$100 \$ 0.00 0 Petition is hereby made under 37 CFR 1.136(a) to extend the time for response to the Office Action to and through _____, comprising an extension of the shortened statutory period of: one month (\$60) three months (\$510) two months (\$225) four months (\$795) TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$ 0.00 Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted. A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed. A check in the amount of \$ is attached. Charge \$ to Deposit Account X No additional fee is required. 8/19/2005 Date Reg. No. 43,654 CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8 I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office facsimile number (571) 273-8300 on August 19, 2005. Number of Pages: 3 (including TRANSMITTAL LETTER) Thomas H, Ham

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Attorney Docket No. INK-001

PATENT APPLICATION

AUG 19 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): In Kwon Jeong

Group Art Unit: 3723

Serial No. 10/765,613

Confirmation No. 1365

Filed: January 27, 2004

Examiner: Wilson, Lee D.

For:

APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR

WAFERS USING ONE OR MORE POLISHING SURFACES

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir/Madam:

In the Office Action dated July 19, 2005, the Examiner has asked the Applicant to elect from one of the following two groups:

Group I: Claims 1-9, 17-23 and 29, drawn to an apparatus, classified in class 451, subclass 11.

Group II: Claims 10-16 and 24-28, drawn to a method, classified in class 451, subclass 28,

CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademurk Office facsimile number (571) 273-8300 on August 19, 2005.

Number of Pages: 3 (including TRANSMITTAL LETTER)

Typed Name: Thomas H. Ham

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In response, Applicant elects with traverse Group I: Claims 1-9, 17-23 and 29, drawn to an apparatus, classified in class 451, subclass 11. However, Applicant respectfully asserts that the inventions of Groups I and II are not distinct from each other since the apparatus as claimed can only be used to practice processes that require an object to be pivoted or transferred. Therefore, Applicant respectfully requests that the restriction requirement be withdrawn.

Although the Office Action states that claim 1-29 are pending in the patent application, there are actually claims 1-38 that are pending in the patent application.

Applicant respectfully suggests that claims 1-38 in the patent application are distinct over the prior art and that the application is in condition for allowance. Accordingly, a notice of allowance is earnestly solicited.

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Respectfully submitted,

In Kwon Jeong

Date: 8/19/2005

₿y:

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